

Appl. No. : 09/654,845 Confirmation No. 6844  
Applicant : Jifa Hao, et al.  
Filed : September 1, 2000 Art Unit: 2811  
Title : POWER SEMICONDUCTOR DEVICE WITH HIGH  
AVALANCHE CAPABILITY AND PROCESS FOR  
FORMING SAME  
Examiner : Ori Nadav  
Docket No. : 3016714 (17732.6323.00)  
Customer No. : 44,331

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## **SUPPLEMENTAL AMENDMENT**

Sir:

In response to the very helpful Response to Arguments included with the Advisory Action dated January 24, 2007 and the Final Office Action dated November 1, 2006 in the above-referenced application, applicants submit this Supplemental Amendment in order to advance the prosecution of this case.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.